

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: KIKUO MAEDA ET AL.)
Serial No.: 10/807,774) Group Art Unit: 1792
Filed: March 23, 2004)
For: THIN FILM FORMING APPARATUS) Examiner: Crowell, Anna M
AND THIN FILM FORMING METHOD) Confirmation No. 4282
Customer No.: 23413

RESPONSE TO RESTRICTION REQUIREMENT

Via EFS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement mailed February 6, 2008, Applicant submits the following response.